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CLAIMS

- 1. A microfiltration filter cartridge comprising a micro-porous filtration membrane, supports, a core, an outer cover and end plates, all the components being formed of a polysulfone based polymer, wherein melting molding members in the component is subjected to annealing.
- 2. The microfiltration filter cartridge according to claim 1, wherein the melting molding members subjected to the annealing is end plates.
- 3. The microfiltration filter cartridge according to claim 1 or 2, wherein all of the micro-porous filtration membrane, the supports, the core, the outer cover and the end plates which are the components are formed of polyethersulfone.
- 4. The microfiltration filter cartridge according to any of claims 1 to 3, wherein a dimension in an axial direction of a window of each of the outer cover and the core is 1 mm to 3 mm.
- 20 5. The microfiltration filter cartridge according to any of claims 1 to 4, wherein a primary side and/or secondary side supports/support are/is formed by a micro-porous film provided with a large number of very fine concave portions and/or convex portions.
- 25 6. The microfiltration filter cartridge according to

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any of claims 1 to 5, wherein the micro-porous filtration membrane has a water bubble point of 0.3 MPa or more and the supports has a water bubble point of 0.15 MPa or less.

- 7. A method of manufacturing a microfiltration filter cartridge comprising a micro-porous filtration membrane, supports, a core, an outer cover and end plates, all the components being formed of a polysulfone based polymer, wherein melting molding members in the component is subjected to annealing.
- 10 8. The method of manufacturing a microfiltration filter cartridge according to claim 7, wherein the melting molding members to be annealed is end plates.
 - 9. The method of manufacturing a microfiltration filter cartridge according to claim 7 or 8, wherein all of the micro-porous filtration membrane, the supports, the core, the outer cover and the end plates which are
 - the components are formed of polyethersulfone.

then dried in a clean oven.

- 10. The method of manufacturing a microfiltration filter cartridge according to any of claims 7 to 9, wherein the cartridge is cleaned with a flow of warm ultrapure water at 50° C to 100° C after assembling and is
- 11. A method of filtrating a wafer cleaning solution for a semiconductor integrated circuit, wherein the microfiltration filter cartridge according to any of

claims 1 to 6 is used to start to filtrate chemicals without prewetting through alcohol.